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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/533,030	04/26/2005	Sciji Kai	81784.0329	2194	
26021 HOGAN & HA	7590 12/14/200° RTSON L. L. P	7	EXAMINER		
1999 AVENUE	OF THE STARS		LOPEZ ESQUERRA, ANDRES		
SUITE 1400 LOS ANGELES, CA 90067			ART UNIT	PAPER NUMBER	
	,		2818		
			MAIL DATE	DELIVERY MODE	
			12/14/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

			TH		
	Application No.	Applicant(s)			
	10/533,030	KAI ET AL.			
Office Action Summary	Examiner	Art Unit			
·	Andrés López-Esquerra	2818			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address	; 		
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tin vill apply and will expire SIX (6) MONTHS from a cause the application to become AB ANDONE	N. nely filed the mailing date of this communi D (35 U.S.C. § 133).			
Status	·				
 1) ⊠ Responsive to communication(s) filed on 05 No. 2a) ☐ This action is FINAL. 2b) ⊠ This 3) ☐ Since this application is in condition for allowar closed in accordance with the practice under Exercise. 	action is non-final. nce except for formal matters, pro		its is		
Disposition of Claims	x parte quayre, 1000 o.b. 11, 10				
4) ☐ Claim(s) 1-10 is/are pending in the application. 4a) Of the above claim(s) 1-4 and 8-10 is/are w 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 5-7 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	ithdrawn from consideration.				
Application Papers					
9) The specification is objected to by the Examine	r.				
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.					
Applicant may not request that any objection to the	•				
Replacement drawing sheet(s) including the correcting 11) The oath or declaration is objected to by the Ex					
Priority under 35 U.S.C. § 119			•		
12) ⊠ Acknowledgment is made of a claim for foreign a) ⊠ All b) □ Some * c) □ None of: 1. ☑ Certified copies of the priority documents 2. □ Certified copies of the priority documents 3. □ Copies of the certified copies of the prior application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicati ity documents have been receive (PCT Rule 17.2(a)).	on No ed in this National Stage	e .		
Attachment(s) 1) Motice of References Cited (PTO-892)	4) Interview Summary				
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 04/26/2005, 12/05/2006.	Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:				

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DETAILED ACTION

Election/Restrictions

1. Applicant's election without traverse of Claims 5 – 7 in the reply filed on November 5, 2007 is acknowledged.

Specification

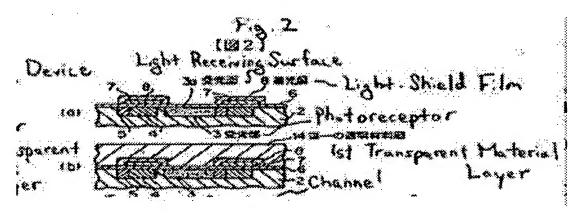
2. The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed.

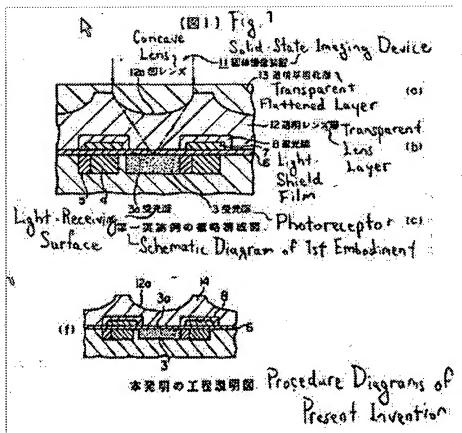
Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

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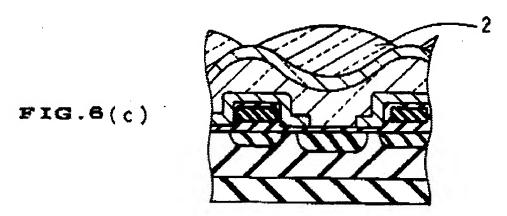
5. Claims 5 – 7 are rejected under 35 U.S.C. 103(a) as being unpatentable over Jyunya Suzuki et al. (Japan Publication No. 9-27608) (Suzuki) in view of Sano et al US 6,030,852 (Sano).





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- 6. As for claim 5, Suzuki discloses and shows in Figs. 1, 2c, and 2f a method of manufacturing a solid state imaging device comprising:
 - an insulating film (12/14) etching step for etching a fiat light transmitting insulating film along a predetermined mask pattern to form convex regions between adjacent micro lenses (Suzuki discloses (Pages 10 12, [0017] [0018]) the use of etching to create the convex form of the layer);
 - b. a lens film laminating step for laminating a light transmitting lens film (13) on the insulating film; and;
 - c. an etching step by etch back processing of the lens film (Suzuki discloses (Pages 10 11, [0017] [0018]) that the flattening process of layer 17, which is also applied to the layer 13, is done by etching the same).
- 7. Suzuki fails to disclose the creation of concave regions over the convex regions when flattering the lens film (13).



8. Sano discloses (Col. 11, lines 15 - 30) and shows in Fig. 6(a) - 6(c) the method of crating a concave lens (2) on top of a convex region in a solid state imaging device by etching.

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9. Sano is evidence that ordinary workers in the art would find a reason, suggestion or motivation to create a concave lens on top of the convex region of the solid state imaging device.

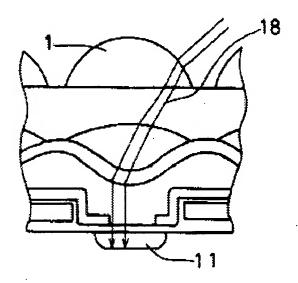


FIG. 3

- 10. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention was made to modify Suzuki by etching the flattering layer (13) all the way until creating a concave lens on top of the convex region of the solid state imaging device for advantages such as improving the sensitivity of the structure when the diaphragm of the optical lens is open (Col. 12, lines 3 7) as shown in Fig. 3.
- 11. As for the limitation of "wherein the lens film has a refractive index higher than that of a substance provided in a layer above the lens film", the same is present since the only substance in Fig. 1 over the lens film (13), which has a refractive index of about 1.5 1.7 (Page 8, [0013]), is air with a refractive index of about 1.

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12. As for claims 6-7, Suzuki discloses (Pages 10-12, [0017]-[0018]) the steps of anisotropically etching the insulating film (12/14) follow by isotropically etching the same and also discloses (Page 8, [0013]) that the refractive index of the lens film (13) is about 1.5-1.7 and the insulating film is about 1.2-1.4.

Conclusion

13. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. US 2003/0168678, US 2005/0110052, and US 2001/0036014.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andrés López-Esquerra whose telephone number is (571) 272-9753. The examiner can normally be reached on M - Th 6:30-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Steven H. Loke can be reached on (571) 272 - 1657. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Andrés López-Esquerra Examiner Art Unit 2818

ALE 🌡

DAVID VU PRIMARY EXAMINER